

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/234,233  
Filing Date ..... January 20, 1999  
Inventor..... Weimin Li, et al  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2818  
Examiner ..... D. Le  
Attorney's Docket No..... MI22-1035  
Title: Semiconductor Processing Methods

**INFORMATION DISCLOSURE STATEMENT**

References – See Attached Form PTO-1449


In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patent listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

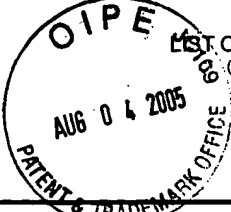
This Supplemental Information Disclosure Statement is being filed after the filing of a Request for Continued Examination (RCE) Application and prior to the receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.


Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 04 Aug 2005

By:   
James E. Lake  
44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1035		SERIAL NO. 09/234,233		
 <p style="text-align: center;">LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Weimin Li, et al.				
				FILING DATE January 20, 1999		GROUP 2818		
<b>U.S. PATENT DOCUMENTS</b>								
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	5,711,987	01/1998	Bearinger, et al.				
	AB	6,632,712 B1	10/2003	Ang, et al.				
	AC	6,790,778	09/2004	Cheng, et al.				
	AD	6,348,407	02/2002	Gupta, et al.				
	AE	5,991,217	11/1999	Tavrow, et a.				
	AF							
	AG							
	AH							
	AI							
<b>FOREIGN PATENT DOCUMENTS</b>								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ	TW 47112A	01/2002	Taiwan				
	AK							
	AL							
<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
<p><small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small></p>								

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<b>U.S. PATENT DOCUMENTS</b>							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2005/0023691	02/2005	Watanabe, et al.			
	AB	2004/012667	07/2004	Smith, et al.			
	AC	2004/0175933	09/2004	Shishida, et al.			
	AD	2003/0173671	09/2003	Hironaga, et al.			
	AE	2003/0164354	09/2003	Hsieh, et al.			
	AF	2002/0016085	02/2002	Huang, et al.			
	AG						
	AH						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Subclass	Translation
	AI						Yes No
	AJ						
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<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>							
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